EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
S12	1477	(438/123).CCLS.	US-PGPUB; USPAT; USOCR	OR	OFF	2006/11/17 14:33
S13	389	(257/642).CCLS.	US-PGPUB; USPAT; USOCR	OR	OFF	2006/11/17 14:24
Si4	229	(S12 S13) and @pd>"20051201"	US-PGPUB; USPAT; EPO; JPO; IBM_TDB	OR	ON	. 2006/11/17 14:25
S15	5068	((427/304,305) or (438/687,627, 643,653)).CCLS.	US-PGPUB; USPAT; USOCR	OR	OFF	2006/11/17 14:26
S16	373	S15 and @pd>"20051201"	US-PGPUB; USPAT; EPO; JPO; IBM_TDB	OR	ON	2006/11/17 14:28
S17	302	(S12 S13 S15) and (SAM (self\$1assembled adj monolayer) monolayer)	US-PGPUB; USPAT; EPO; JPO; IBM_TDB	OR	ON	2006/11/17 14:38
S18	151	S17 and (@ad<"20001012" @rlad<"20001012")	US-PGPUB; USPAT; EPO; JPO; IBM_TDB	OR	ON	2006/11/17 14:39
S19	52138	((self\$1assembled (self adj assembled)) adj monolayer) monolayer	US-PGPUB; USPAT; EPO; JPO; IBM_TDB	OR	ON	2006/11/17 14:39
S20	31697	S19 and (@ad<"20001012" @rlad<"20001012")	US-PGPUB; USPAT; EPO; JPO; IBM_TDB	OR	ON	2006/11/17 14:39
S21	3433	((self\$1assembled (self adj assembled)) adj monolayer)	US-PGPUB; USPAT; EPO; JPO; IBM_TDB	OR	ON	2006/11/17 14:39
S22	1170	S21 and (@ad<"20001012" @rlad<"20001012")	US-PGPUB; USPAT; EPO; JPO; IBM_TDB	OR	ON	2006/11/17 14:40
S23	1082	S22 and (substrate wafer)	US-PGPUB; USPAT; EPO; JPO; IBM_TDB	OR	ON	2006/11/17 14:40
S24	541	S23 and (copper Cu)	US-PGPUB; USPAT; EPO; JPO; IBM_TDB	OR	ON	2006/11/17 14:41

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S25	308	S24 and diffus\$5	US-PGPUB; USPAT; EPO; JPO; IBM_TDB	OR	ON	2006/11/17 14:41
S26	5	S23 and ((copper Cu) with diffus\$5)	US-PGPUB; USPAT; EPO; JPO; IBM_TDB	OR	ON	2006/11/17 14:43
S27	O	S12 and (monolayer and copper and diffus\$5).clm.	US-PGPUB	OR	ON	2006/11/17 15:05
S28	814	(438/623).CCLS.	US-PGPUB; USPAT; USOCR	OR	OFF	2006/11/17 15:04
S29	389	(257/642).CCLS.	US-PGPUB; USPAT; USOCR	OR	OFF	2006/11/17 15:05
S30	0	(S28 S29) and (monolayer and copper and diffus\$5).clm.	US-PGPUB	OR	ON	2006/11/17 15:05